



Attorney's Docket No.: 004711/P1

Patent

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of: )

Steven Verhaberbeke et al. )

Application No: 09/891,849 )

Examiner: Markoff, Alexander

Filed: June 25, 2001 )

Art Unit: 1792

For: METHOD AND APPARATUS FOR  
WAFER CLEANING )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT UNDER  
37 C.F.R. §1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 1792**

**AMENDMENT AFTER FINAL**

Dear Sir:

This is in response to the Office Action mailed March 21, 2008. Pursuant to 37 C.F.R. § 1.116 Applicant respectfully requests the Examiner to enter this Amendment after Final which complies with the Examiner's requirements of form expressly set forth in the previous Office Action mailed March 21, 2008.

**FIRST CLASS CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to MAIL STOP \_\_\_\_\_

COMMISSIONER FOR PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450

U.S. Patent and Trademark Office, Washington, D.C. 20231 on May 12, 2008

Date of Deposit

Teresa Mattox

Name of Person Mailing Correspondence

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Signature

May 12, 2008

Date